

Notice of References Cited	Application/Control No. 10/612,040	Applicant(s)/Patent Under Reexamination CHOI ET AL.	
	Examiner Tianjie Chen	Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,859,933 B2	02-2005	Park et al.	720/651
*	B	US-6,690,540 B2	02-2004	Hirasaka et al.	360/97.02
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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